

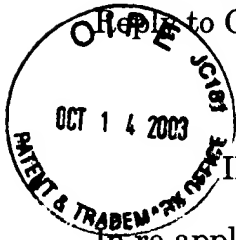
Appl. No. 09/816,643

Attorney Docket No. 81877.0012

Amdt. Dated October 10, 2003

Customer No.: 26021

Reply to Office Action of April 10, 2003



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiyo Nakashima et al.

Serial No: 09/816,643

Confirmation No.: 6862

Filed: March 23, 2001

For: SUBSTRATE PROCESSING
APPARATUS AND SUBSTRATE
PROCESSING METHOD

Art Unit: 1763

Examiner: Kackar, Ram N

I hereby certify that this correspondence
is being deposited with the United States
Postal Service with sufficient postage as
first class mail in an envelope addressed
to:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 10, 2003

Date of ~~Patent Transmission~~ *deposit* *Y.C.*

Ying Chen, Reg. No. 50,193

Name

Signature

10/10/03
Date

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated April 10, 2003, the time for response to which is extended three month by the accompanying petition to October 20, 2003, please amend the above-referenced application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.

10/20/2003 MBIZUNES 00000074 09816643

01 FC:1202

18.00 OP